



Attorney Docket 0524-0136.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Tomotaka Yokoyama et al.)
)
Serial No.: 10/761,771)
)
Filed: January 20, 2004)
)
For: Management Technique Of Friction)
Coefficient Based On Surface Roughness,)
Substrate For An Information Recording)
Medium, Information Recording Medium)
And Manufacturing Method Thereof)
)
Art Unit: 1773)
)
Examiner: Leszek B. Kiliman)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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February 14, 2006
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 2/14/06
Signature Date

AMENDMENT B

Sir:

In response to the Office Action of August 15, 2005, a three month extension of time being submitted herewith, please amend the above-identified application as follows: